



1775
MC 98-1451/2554.1
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Robert J. Falster et al.

Art Unit 1775

Serial No. 10/073,506

Filed February 11, 2002

Confirmation No. 6190

For EPITAXIAL SILICON WAFERS WITH NITROGEN STABILIZED OXYGEN
PRECIPITATION NULEI AND PROCESS FOR MAKING SAME

March 12, 2002

Office of Initial Patent Examination's
Customer Service Center
Assistant Commissioner for Patents
Washington, D.C. 20231

SUPPLEMENTAL APPLICATION DATA SHEET

SIR:

Applicants incorrectly listed the first named inventor twice on the Application Data Sheet filed on February 11, 2002 respecting the above-referenced application. In accordance with 37 CFR 1.76(d)(3) & (4), Applicants respectfully submit herewith a Supplemental Application Data Sheet. Applicants also respectfully request a corrected filing receipt reflecting this correction.

Respectfully submitted,

Edward J. Hejlek, Reg. No. 31,525
SENNIGER, POWERS, LEAVITT & ROEDEL
One Metropolitan Square, 16th Floor
St. Louis, Missouri 63102
(314) 231-5400

EJH/dep
*Enclosure

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